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Docket No.: KSM-0226
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Masayoshi ICHIKI et al.

Application No.: 10/509,160

Confirmation No.: 5098

Filed: September 28, 2004

Art Unit: 1754

For: HIGH TEMPERATURE DENITRATION
CATALYSTS AND PROCESSES FOR
PREPARING SAME

Examiner: WARTALOWICZ, PAUL A

STATUS INQUIRY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

It is respectfully requested that the attorney named below be advised of the status of the above-identified application. Please advise us of when we might expect to receive an Office Action from the Patent and Trademark Office.

Applicant believes no fee is due with this response. However, if a fee is due, please charge our Deposit Account No. 18-0013, under Order No. KSM-0226 from which the undersigned is authorized to draw.

Dated: October 20, 2006

Respectfully submitted,

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